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Bib Data Sheet

CONFIRMATION NO. 3099

SERIAL NUMBER 09/387,857	FILING DATE 09/01/1999 RULE	CLASS 438	GROUP ART UNIT 2822	ATTORNEY DOCKET NO. 1776/00039	
APPLICANTS FUMITAKA SUGAYA, TOKYO, JAPAN; ** CONTINUING DATA ***** THIS APPLICATION IS A DIV OF 09/059,590 04/14/1998 PAT 6,288,423 <i>yes</i> ** FOREIGN APPLICATIONS ***** <i>yes</i> JAPAN 9-116322 04/18/1997 <i>OK</i> IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 09/20/1999					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and <i>OK</i> Acknowledged Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 33	TOTAL CLAIMS 18	INDEPENDENT CLAIMS 5
ADDRESS POLLOCK VANDE SANDE & PRIDDY P O BOX 19088 WASHINGTON ,DC 200363425					
TITLE A Method For Fabricating A Semiconductor Storage Device Having An Increased <i>Dielectric Film</i> <i>OK</i> Dielectric Film Area <i>8/17/04</i>					
FILING FEE RECEIVED 916	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		